

DOCKET: CU-3413

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

APPLICANT: Kiyoshi OOI et al)
SERIAL NO: 10/693,216) Group Art Unit: 2813
FILING DATE: October 24, 2003) Examiner:
TITLE: SUBSTRATE FOR CARRYING A) Blum, David S.
SEMICONDUCTOR CHIP AND A)
MANUFACTURING METHOD THEREOF) Allowed: 10/28/2005
) Conf. No. 2275

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**REQUEST FOR ACKNOWLEDGEMENT OF
PRIORITY CLAIM**

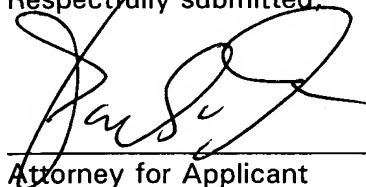
Dear Sir:

It is noted that the Patent Office has not formally acknowledged the claim for foreign priority under 35 USC 119(a)-(d).

A certified copy of the Japanese application was filed on October 24, 2003. Enclosed is a copy of the return postcard, date-stamped by the PTO acknowledging receipt.

It is urgently requested that the Office confirm receipt of the priority document as well as formally acknowledge the claim for foreign priority in this case.

Respectfully submitted,



Attorney for Applicant

December 1, 2005

Date

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The Patent & Trademark Office acknowledges and has stamped hereon the date of receipt of the item checked below:

967 332755

- | | |
|---|---|
| <input checked="" type="checkbox"/> New pat./design PCT appln. | <input checked="" type="checkbox"/> Assignment & Recordal Cover Sheet |
| <input checked="" type="checkbox"/> Transmittal letter SB/05 | <input checked="" type="checkbox"/> CC of priority document |
| <input checked="" type="checkbox"/> Fee Transmittal (PTO/SB/17) | <input type="checkbox"/> Application Data Sheet |
| <input checked="" type="checkbox"/> 25 pages spec./abstract | <input type="checkbox"/> Amendment/Response |
| <input checked="" type="checkbox"/> 7 pages of 20 claims | <input type="checkbox"/> Request for Extension |
| <input checked="" type="checkbox"/> 8 sheets of drawings | <input checked="" type="checkbox"/> Fee \$810 |
| <input checked="" type="checkbox"/> Declaration/Power | <input checked="" type="checkbox"/> Other Inf. Disc. Statement |

w/PTO-1449 & 2 refs

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SERIAL NO: _____

FILED: _____

TITLE: SUBSTRATE FOR CARRYING A
SEMICONDUCTOR CHIP AND A MANUFACTURING
METHOD THEREOF

DOCKET: CU-3413 DATE: 10/24/03

03945 U.S. PTO
10/693216

